
Declaration TA-Luft & ISO 15848-1 Fugitive Emission

We hereby declare that our products:

- Needle Valves and Process Instrumentation Manifolds **IV1X – IV2X – IV3X – IV5X**
- Process and Instrumentation Monoflanges **IVM**

with the sealing systems shown in Appendix A, comply with the tightness criteria of the following Standards:

VDI 2440-TA-LUFT

($1,5 \times 10^{-6}$)

ISO 15848-1

ISO-FE-AH-C01-SSA1-t(-29°C;+180°C)-ISO15848-1

For further information, do not hesitate to contact us at:

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Signed of behalf of

WIKA Instruments Italia S.r.l

Montegaldella, 11th March 2019



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